

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : David L. Chapek
Serial No. : 09/605,293
Filed : June 28, 2000
Title : SEMICONDUCTOR DEVICES INCLUDING A LAYER OF
POLYCRYSTALLINE SILICON HAVING A SMOOTH
MORPHOLOGY
Docket No. : MIO 0037 VA/40509.118 (96-0831.01)
Examiner : N. Drew Richards
Art Unit : 2815
Confirm No. : 5927

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

EFS Web Electronic Submission
June 23, 2008

RESPONSE TO OFFICE ACTION

This Amendment is being filed in response to the non-final Office Action mailed March 28, 2008. Reconsideration and reexamination of the application is respectfully solicited in light of the remarks below.